

**Amendments to the Specification**

Please replace paragraph [0001] with the following amended version of that paragraph:

This application is a continuation-in-part claiming priority under 35 USC 120 from US Patent Application No. 10/404,693 filed March 31, 2003 by Humayun, et al., and titled "METHOD FOR FORMING POROUS FILMS BY POROGEN REMOVAL COMBINED WITH IN SITU SURFACE MODIFICATION." This application is incorporated herein by reference for all purposes. This application is also related to US Patent Application No. 10/672,305, filed September 26, 2003; US Patent Application No. 10/672,311, filed September 26, 2003; and US Patent Application No. 10/807,680, filed March 23, 2004.